Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	702/35.ccls. and ((focus\$3 near ion near beam) same ((gas gaseous) or sublimat\$4) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:40
L2	0	702/36.ccls. and ((focus\$3 near ion near beam) same ((gas gaseous) or sublimat\$4) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:40
L3	0	382/149.ccls. and ((focus\$3 near ion near beam) same ((gas gaseous) or sublimat\$4) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:40
L4	0	438/12.ccls. and ((focus\$3 near ion near beam) same ((gas gaseous) or sublimat\$4) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:40
L5	0	((focus\$3 near ion near beam) same ((gas gaseous) or sublimat\$4) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask)).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:40
L6	2	((focus\$3 near ion near beam) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask)).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:41
L7	0	702/35.ccls. and ((focus\$3 near ion near beam) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:41
L8	0	702/36.ccls. and ((focus\$3 near ion near beam) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:41
L9	0	382/149.ccls. and ((focus\$3 near ion near beam) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle photomask))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:41

L10	. 0	438/12.ccls. and ((focus\$3 near ion near beam) and pump\$3 with remov\$3 and (wafer semiconductor mask reticle	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2006/01/13 11:41
		photomask))				